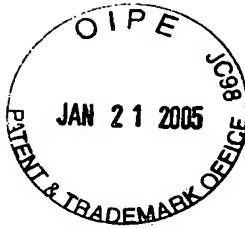


Attorney Docket: 081468-0307255
Client Reference: P-1514.010-US



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
LEON MARTIN LEVASIER ET AL.
Application No.: 10/736,230

Confirmation Number: 3133

Group Art Unit: 2851

Filed: December 16, 2003

Examiner: Hung Nguyen

Title: LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM, DEVICE
MANUFACTURING METHOD, AND DEVICE MANUFACTURED THEREBY

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2004, Applicants hereby elect the invention of Group I, which includes claims 1-48, for examination. This election is made without traverse. Unelected claims 49-56 are withdrawn from further consideration in this application.

Prompt and favorable examination on the merits is respectfully requested.

Respectfully submitted,

PILLSBURY WINTHROP LLP

SEAN L. INGRAM

Reg. No. 48,283

Tel. No. 703.905.2107

Fax No. 703.905.2500

Date: January 21, 2005
P.O. Box 10500
McLean, VA 22102
(703) 905-2000